

**REMARKS**

Applicants are grateful for the allowance of the pending claims in the present application and wish to proceed with the issue of a patent. However, Applicants respectfully disagree with the Examiner's statement of reasons of allowance. The Examiner has used wording different from that used in the main independent claim (claim 83) to describe the claimed invention. In particular, Applicants note that the Examiner has referred to the claimed method as being characterised by "modifying" the surface of the first electrode, whereas the main claim refers to "preparing" the surface of the first electrode. Applicants respectfully submit that the broader concept of a preparation of the surface is the appropriate feature of the invention.

Respectfully submitted,

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